

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : S. Yamazaki et al.                      Art Unit : Unknown  
Serial No. : New Div. Application                      Examiner : Unknown  
Filed : August 26, 2003  
Title : SEMICONDUCTOR THIN FILM AND ITS MANUFACTURING METHOD  
AND SEMICONDUCTOR DEVICE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Prior to examination, please amend the application as indicated on the following pages.

**Amendments to the specification** begin at page 2 of this paper.

**Amendments to the claims** are reflected in the listing of claims which begins at page 3 of this paper.

**Remarks** begin at page 5 of this paper.